



SFK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Robert Bristol et al.

§ Art Unit: 1795

§

§ Examiner: Kathleen Duda

§

§ Atty Docket: ITL.1023US
P16710

§

§ Assignee: Intel Corporation

§

Serial No.: 10/679,816

Filed: October 6, 2003

For: Enhancing Photoresist Performance
Using Electric Fields

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO OFFICE ACTION

Sir:

In response to the office action mailed October 17, 2007, please amend the above-referenced patent application as follows:

Date of Deposit: January 8, 2008

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
Cynthia L. Hayden